

<b>Notice of References Cited</b>	Application/Control No. 09/836,857	Applicant(s)/Patent Under Reexamination IWAMATSU, SEIICHI	
	Examiner David A Vanore	Art Unit 2881	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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#### NON-PATENT DOCUMENTS

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